

Electronic Acknowledgement Receipt

EFS ID:	1294500
Application Number:	10769907
International Application Number:	
Confirmation Number:	9780
Title of Invention:	Film formation apparatus and film formation method
First Named Inventor/Applicant Name:	Shunpei Yamazaki
Customer Number:	26171
Filer:	John F. Hayden/Andrea Turner
Filer Authorized By:	John F. Hayden
Attorney Docket Number:	07977-302002
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1	Information Disclosure Statement (IDS) Filed	07977-302002-IDS.pdf	326628	no	2

Warnings:

Information:

This is not an USPTO supplied IDS fillable form

2	Foreign Reference	07977-302002-refAL.pdf	788790	no	12
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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.